# SUPPORTING INFORMATION

# Porous aluminium decorated with rhodium nanoparticles – preparation and use as platform for UV SERS

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#### Supporting Note #1 – Additional SEM micrographs



Fig. S1. SEM micrograph of the prepared sample (a)



Fig. S2. SEM micrograph of the prepared sample (b)



Fig. S3. SEM micrograph of the prepared sample (c)



Fig. S4. SEM micrograph of the prepared sample (d)



Fig. S5. SEM micrograph of the prepared sample (e)



Fig. S6. SEM micrograph of the prepared sample (f)

### **Supporting Note #2** – AFM Maps



Fig. S7. AFM map of the prepared sample (b)



Fig. S8. AFM map of the prepared sample (c)



Fig. S9. AFM map of the prepared sample (d)



Fig. S10. AFM map of the prepared sample (e)



Fig. S11. SEM micrograph of the prepared sample (f)

## Supporting Note #3 – Reflectance Spectra



Fig. S12. Total Reflectance spectra of the samples.

**Supporting Note #4** – Additional FEM simulations



Fig. S13. FEM simulations of a Rh nanoparticle deposited on an Al film. Excitation wavelength 266 nm (illumination from the top). Electromagnetic field enhancement factor. (a) Rh nanoparticle with a diameter of 100 nm; (b) Rh nanoparticle with a diameter of 100 nm on a film of Al considering an additional 2 nm Al2O3 layer in the gap; (c) Rh nanoparticle with a diameter of 150 nm; (d) Rh nanoparticle with a diameter of 150 nm on a film of Al considering an additional 2 nm Al2O3 layer in the gap; (e) Rh nanoparticle with a diameter of 200 nm; (f) Rh nanoparticle with a diameter of 200 nm on a film of Al considering an additional 2 nm Al2O3 layer in the gap.